



ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

March 23, 2026

IGI Report Number **LG768622837**

Description LABORATORY GROWN DIAMOND

Shape and Cutting Style **ROUND BRILLIANT**

Measurements 6.44 - 6.46 X 3.93 MM

GRADING RESULTS

Carat Weight 1.01 CARAT

Color Grade D

Clarity Grade VS 1

Cut Grade IDEAL

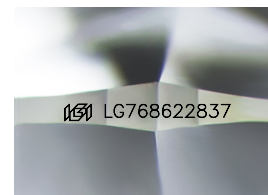
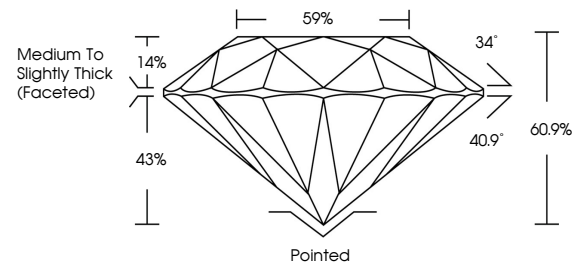
ADDITIONAL GRADING INFORMATION

Polish **EXCELLENT**Symmetry **EXCELLENT**Fluorescence **NONE**Inscription(s) LG768622837

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

LG768622837
Report verification at lgi.org

PROPORTIONS



Sample Image Used

COLOR

D E F G H I J Faint Very Light Light

CLARITY

FL	IF	VVS ¹⁻²	VS ¹⁻²	SI ¹⁻²	I ¹⁻³
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included

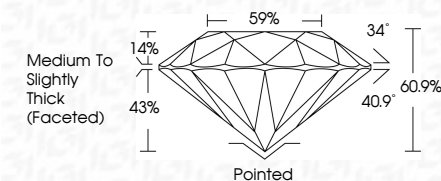
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GI Report No LG768622837
ROUND BRILLIANT

1.01 CARAT	VS 1	IDEAL	60.9%	59%	Medium to Slightly Thick (Faceted)	Pointed	EXCELLENT	NONNE	4mm (2748102932)
Color Grade	Clarity Grade	Cut Grade	Depth	Table	Girdle	Culet	Polish	Symmetry	Fluorescence

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